Supplementary Information for:

## Effect of surfactants on the electrohydrodynamic jet printing and the performance in organic fieldeffect transistors

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**Figure S1.** OM images for various jetting modes: (a) MWCNT/TX100 composites (b) MWCNT/PSS composites.



**Figure S2.** (a) OM images of MWCNT/NaDDBS nanocomposites at the edge of tip during EHD jet printing process. (b) OM images of MWCNT/ NaDDBS printed lines.



**Figure S3.** I-V curves of (a) EHD jet-printed MWCNT/TX100 lines and (b) EHD jet-printed MWCNT/PSS lines.